



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818  
Examiner: Mai Huong C. Tran

In Re PATENT APPLICATION of:

Applicant(s): Akio NAKAMURA

Serial No.: 10/712,090

Filing Date: November 14, 2003

For: SEMICONDUCTOR DEVICE AND  
ITS MANUFACTURING METHOD

Atty Ref.: SAT 198

**RESPONSE TO  
RESTRICTION  
REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Restriction Requirement dated January 28, 2005,  
Applicant elects the invention of Group I, i.e., the subject matter of claims 1  
through 9, for further examination. The election is made without traverse.

Examination of the application on the merits is respectfully requested.

Respectfully submitted,

Robert H. Berdo, Jr.  
Registration No. 38,075  
RABIN & BERDO, PC  
Customer No. 23995  
Telephone: 202-371-8976  
Facsimile: 202-408-0924

February 28, 2005  
Date

RHB:vm

**FEE ENCLOSED:\$**  
**Please charge any further**  
**fee to our Deposit Account**  
**No. 18-0002**